



Sughrue

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March 19, 2004

MAIL STOP PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450



Re: Application of **Toshiro HAYAKAWA**
SURFACE-EMITTING SEMICONDUCTOR LASER ELEMENT
HAVING SELECTIVE-OXIDATION TYPE OR ION-INJECTION
TYPE CURRENT-CONFINEMENT STRUCTURE, InGaAsP
QUANTUM WELL, AND InGaP OR InGaAsP BARRIER LAYERS
Assignee: **FUJI PHOTO FILM CO., LTD.**
Our Ref. **Q80553**

Dear Sir:

Attached hereto is the application identified above comprising thirty-five (35) sheets of the specification, including the claims and abstract, and four (4) sheets of drawings. **The requisite U.S. Government Filing Fee, copies of the executed Declaration and Power of Attorney and the Assignment will be submitted at a later date. Also enclosed is an Information Disclosure Statement and PTO/SB/08 A & B (modified).**

The Government filing fee is calculated as follows:

Total claims	<u>10</u>	-	<u>20</u>	=	<u> </u>	x	\$18.00	=	<u> </u>	\$0.00
Independent claims	<u>1</u>	-	<u>3</u>	=	<u> </u>	x	\$86.00	=	<u> </u>	\$0.00
Base Fee										\$770.00
TOTAL FEE										<u>\$770.00</u>



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Priority is claimed from:

<u>Country</u>	<u>Application No</u>	<u>Filing Date</u>
JAPAN	2003-074904	March 19, 2003

The priority document is enclosed herewith.

Respectfully submitted,
SUGHRUE MION, PLLC

Attorneys for Applicant

By: *Paul D. Zerk Reg. 33,102*
for Darryl Mexic
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